



IAP7 Rec'd PCT/PTO 10 JUL 2006 #7
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 10, 2006

In re the Application of

Naoto NAKAMURA et al.

Application No.: 10/528,069

Filed: March 15, 2005

Docket No.: 122733

For: THERMAL TREATMENT APPARATUS, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING SUBSTRATE

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RECEIVED
4 AUG. 2006
Legal Staff
International Division

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired May 13, 2006, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 181824 in the amount of \$450.00 in payment for:

 Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
 X Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Daniel A. Tanner, III
Registration No. 54,734

JAO:DAT/cfr

6/11/2006 SZEWDIE1 00000079 10528069

01 FC:1252

450.00 OP

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461